

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/595,660 Confirmation No. 4264
Applicant : Yuichiro Shindo
371 Filed : May 3, 2006
Art Unit : 1793
Examiner : Jessee Randall Roe
Customer No. : 00270
Title : HIGH PURITY HAFNIUM, TARGET AND THIN FILM
COMPRISING SAID HIGH PURITY HAFNIUM, AND
METHOD FOR PRODUCING HIGH PURITY HAFNIUM

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment timely filed in response to the non-final Office Action dated September 15, 2008. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.